

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

APPLICANT(S): HWANG, Kwang-Jo CONF.: 5562  
SERIAL NO.: 09/648,111 GROUP: 2815  
FILED: August 25, 2000 EXAMINER: A. R. Wilson  
FOR: METHOD OF PATTERNING A METAL LAYER IN A  
SEMICONDUCTOR DEVICE

**AMENDMENT FILED UNDER 37 CFR §1.111**

**Box Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the non-final Office Action dated April 1, 2009, the following amendments and remarks are respectfully submitted in connection with the above-identified application in this Amendment.

This reply includes Amendments to the Claims and Remarks.